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# Review of Micro-Propulsion Ablative Devices

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*Funded by Air Force Office of Scientific Research through grant F49620-02-1-0084*

Report Documentation Page				Form Approved OMB No. 0704-0188	
Public reporting burden for the collection of information is estimated to average 1 hour per response, including the time for reviewing instructions, searching existing data sources, gathering and maintaining the data needed, and completing and reviewing the collection of information. Send comments regarding this burden estimate or any other aspect of this collection of information, including suggestions for reducing this burden, to Washington Headquarters Services, Directorate for Information Operations and Reports, 1215 Jefferson Davis Highway, Suite 1204, Arlington VA 22202-4302. Respondents should be aware that notwithstanding any other provision of law, no person shall be subject to a penalty for failing to comply with a collection of information if it does not display a currently valid OMB control number.					
1. REPORT DATE <b>21 JUN 2004</b>		2. REPORT TYPE <b>N/A</b>		3. DATES COVERED <b>-</b>	
4. TITLE AND SUBTITLE <b>Review of Micro-Propulsion Ablative Devices</b>				5a. CONTRACT NUMBER	
				5b. GRANT NUMBER	
				5c. PROGRAM ELEMENT NUMBER	
6. AUTHOR(S)				5d. PROJECT NUMBER	
				5e. TASK NUMBER	
				5f. WORK UNIT NUMBER	
7. PERFORMING ORGANIZATION NAME(S) AND ADDRESS(ES) <b>Aerospace Engineering, University of Michigan Ann Arbor 48109 USA</b>				8. PERFORMING ORGANIZATION REPORT NUMBER	
9. SPONSORING/MONITORING AGENCY NAME(S) AND ADDRESS(ES)				10. SPONSOR/MONITOR'S ACRONYM(S)	
				11. SPONSOR/MONITOR'S REPORT NUMBER(S)	
12. DISTRIBUTION/AVAILABILITY STATEMENT <b>Approved for public release, distribution unlimited</b>					
13. SUPPLEMENTARY NOTES <b>See also ADM001793, International Symposium on Energy Conversion Fundamentals Held in Istanbul, Turkey on 21-25 June 2005., The original document contains color images.</b>					
14. ABSTRACT					
15. SUBJECT TERMS					
16. SECURITY CLASSIFICATION OF:			17. LIMITATION OF ABSTRACT <b>UU</b>	18. NUMBER OF PAGES <b>30</b>	19a. NAME OF RESPONSIBLE PERSON
a. REPORT <b>unclassified</b>	b. ABSTRACT <b>unclassified</b>	c. THIS PAGE <b>unclassified</b>			



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# Outline

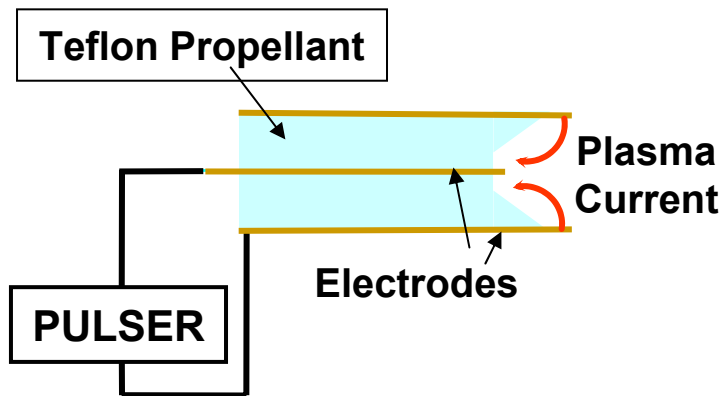
- Examples of micro propulsion ablative devices
- Fundamentals of ablation
- Detailed analysis of specific devices
  - Micro-Pulsed Plasma Thruster
  - Micro-Laser Plasma Thruster
  - Micro-Vacuum Arc Thruster
- Summary and Future Needs



# Micro-Pulsed Plasma Thruster (AFRL)



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100 grams

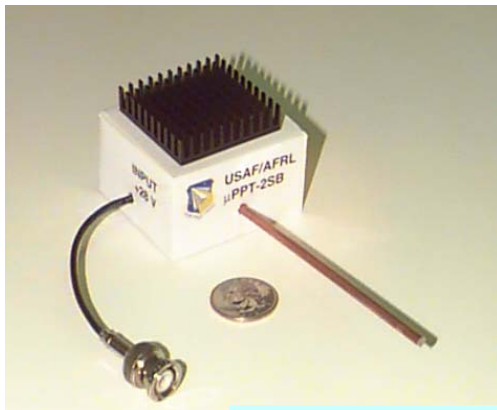
Energy 1-10 J

Thrust-to-Power 1-10  $\mu\text{N/W}$

Simple Engineering

Ablation rate:

10 cm in 100 hour, 1 Hz



Triggerless ignition

## FalconSat

US Air Force Academy, 2005

<100-kg class

**MicroPPTs**



# Micro-PPT Technology Development (JHU-APL)



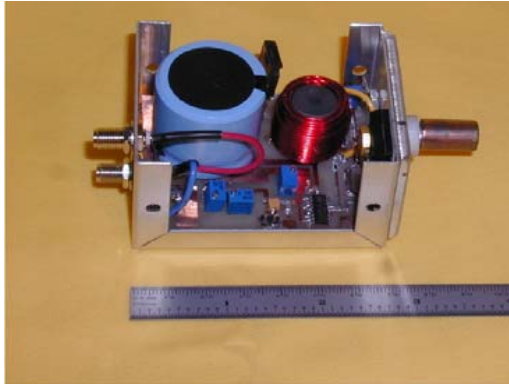
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- APL exploring fundamental effects associated with device scaling
- Examining influence of energy deposition and electrode geometry upon electro-mechanical response
- Developing novel techniques for micro-PPT device characterization



# Micro-Vacuum Arc Thruster (AASC)



Inductive energy storage PPU  
(efficiency of the PPU >90%)

Low mass (<300g)

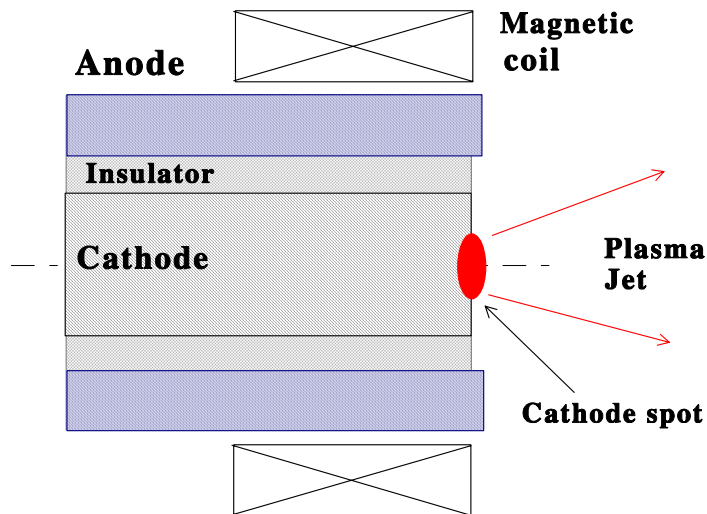
Typical current ~100 A

Voltages of ~25-30 V.

Total efficiency ~10%

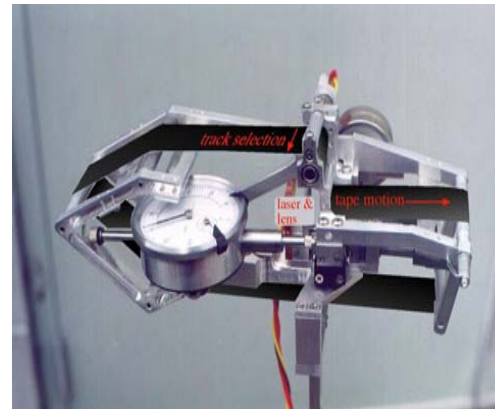
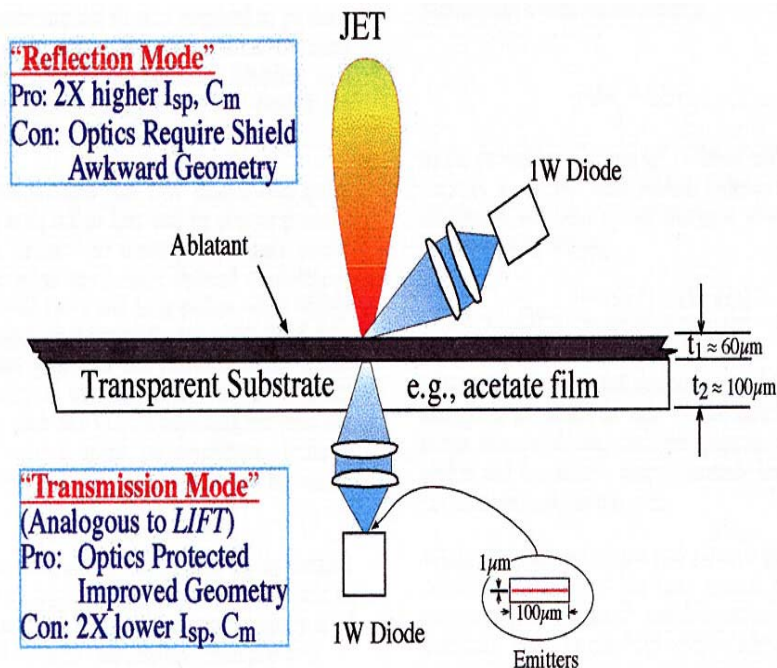
$I_{sp} \sim 1000-3000 \text{ s}$

$T/P \sim 10 \mu\text{N/W}$



# Micro-Laser Plasma Thruster

- micro Laser-ablation Plasma Thruster,  $\mu$ -LPT (Photonics Associates).
- micro chip Laser-ablation Plasma Thruster, (Lincoln Lab).



Power: 2-14 W

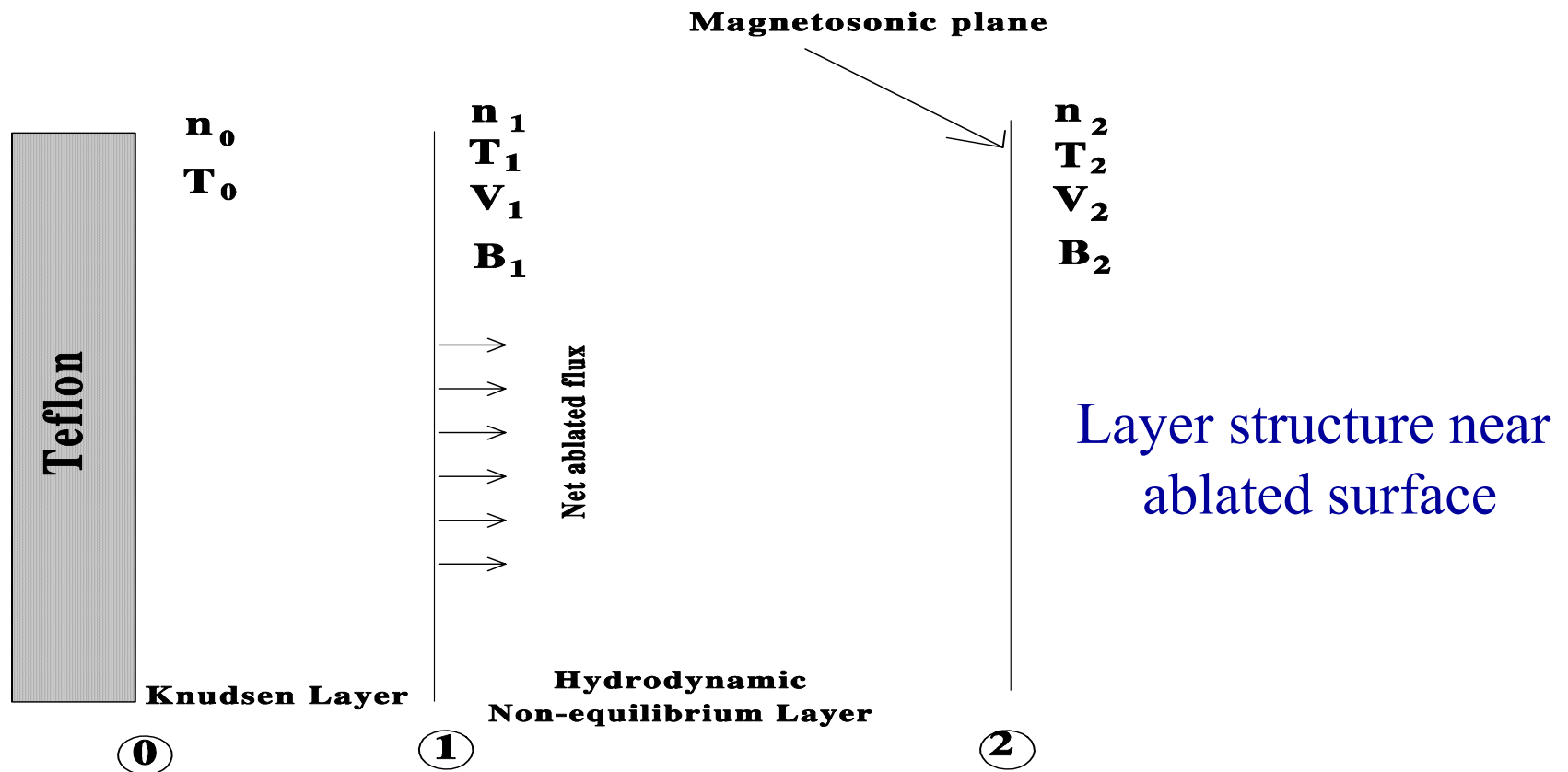
Pulse duration: 3-10 ms

$Q^*$ :  $2 \times 10^7$  J/kg

$C_w$ : 60-100  $\mu N/W$

$I_{sp}$ : 300-1000 s

# Ablation Fundamentals







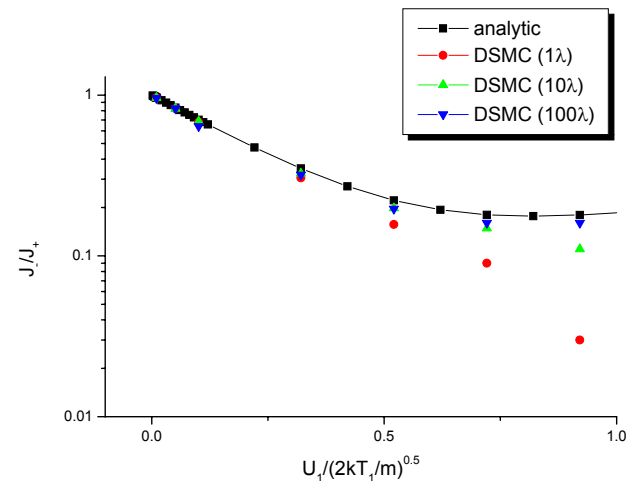
# Kinetic model of the Knudsen Layer (1)

## Analytical and particle (DSMC) approaches:

$f(x, \mathbf{V}) = \xi(x)f_1(\mathbf{V}) + (1 - \xi(x))f_2(\mathbf{V})$   
 where  $\xi(x=0)=1$  and  $\xi(L)=0$  with  $x=0$   
*[Mott-Smith, 1951]*

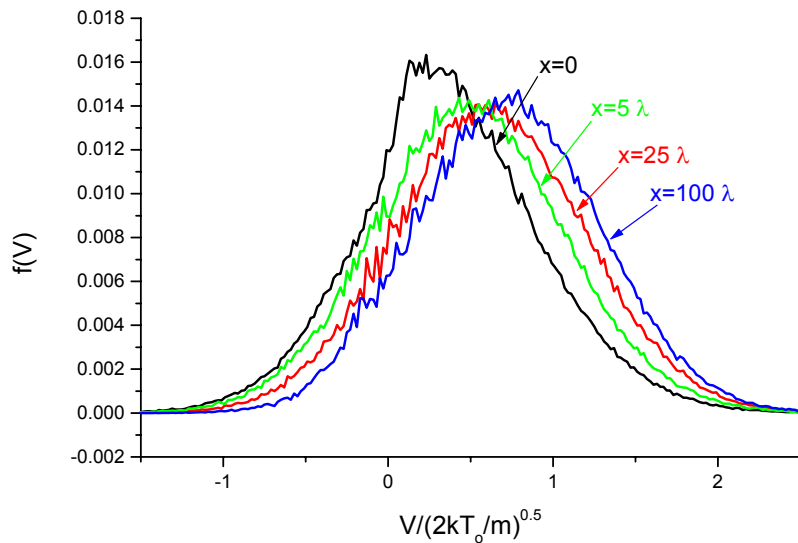
$f_1(\mathbf{V}) = n_0 \beta^{3/2} \exp(-V^2) \quad V_x > 0$   
 $f_1(\mathbf{V}) = \delta f_2(\mathbf{V}) \quad V_x < 0$   
 $f_2(\mathbf{V}) = n_1 \beta^{3/2} \exp(-(v-U)^2)$   
*[Anisimov, 1968]*

$\int V_x f(\mathbf{V}) d\mathbf{V} = \text{const}$	(mass)
$\int V_x^2 f(\mathbf{V}) d\mathbf{V} = \text{const}$	(momentum)
$\int V_x V^2 f(\mathbf{V}) d\mathbf{V} = \text{const}$	(energy)

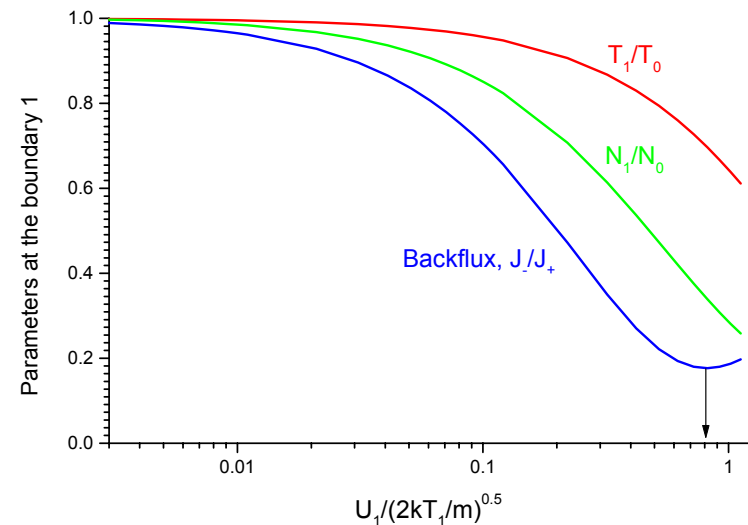


# Kinetic model of the Knudsen Layer (2)

Particle distribution function. DSMC



Parameters at the Knudsen layer edge



# Hydrodynamic Layer

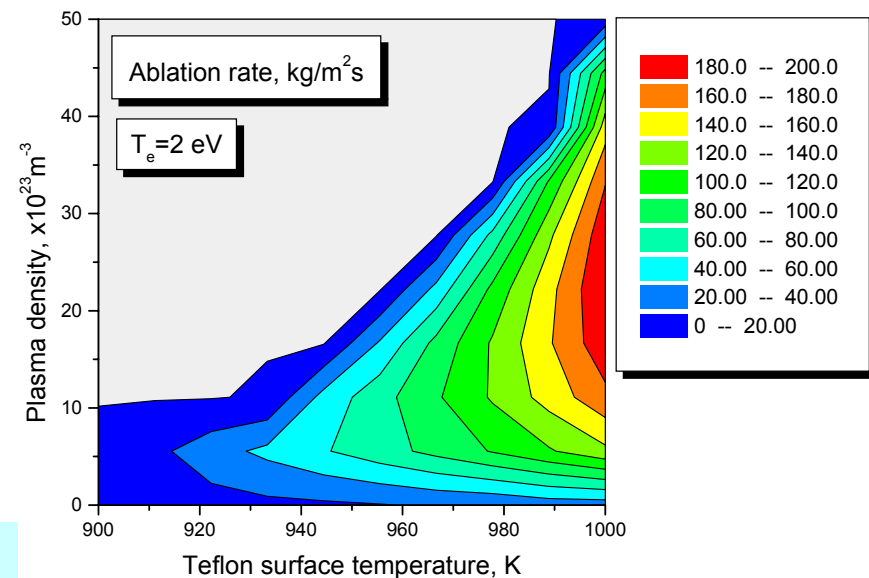
$$d(nV) = 0$$

$$M(nV) \frac{dV}{dx} = - \frac{d(nkT)}{dx} + j \times B$$

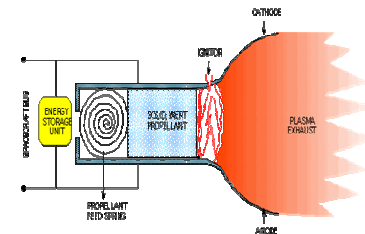
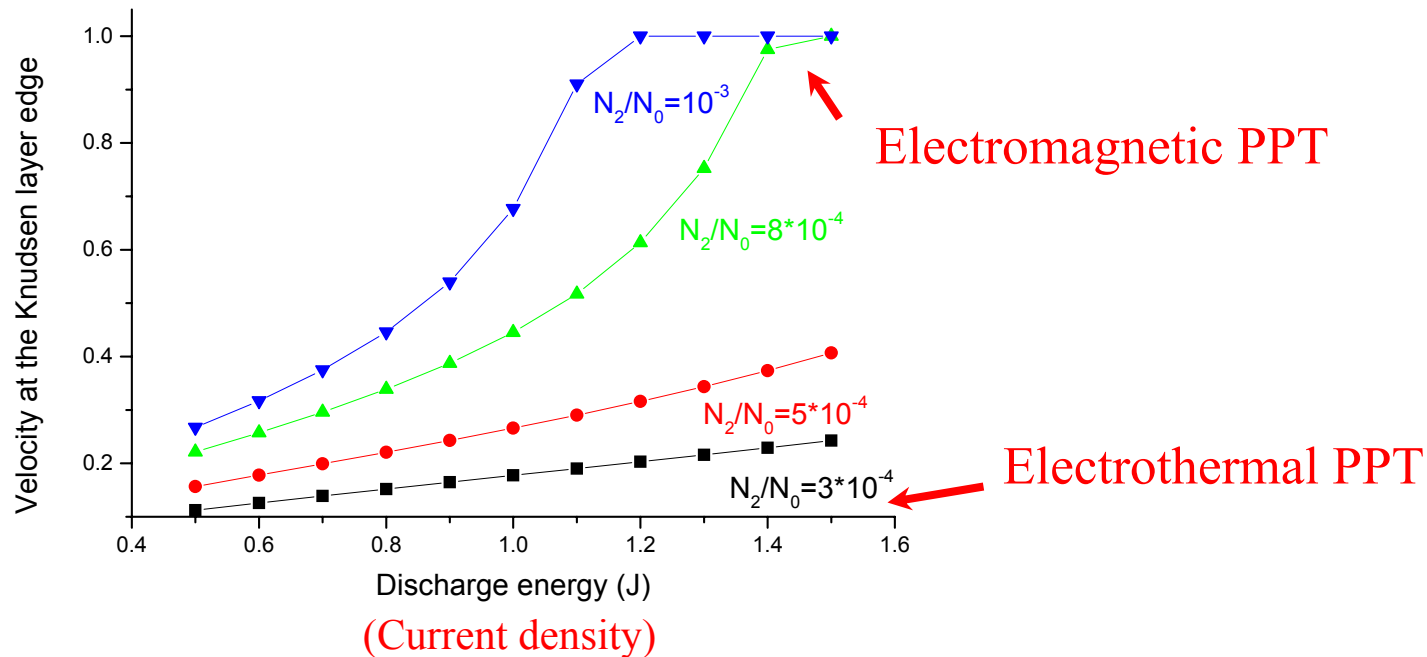
$$\frac{MV_1^2}{2kT_1} = \frac{\frac{n_1}{2} - \frac{T_2 n_2}{2T_1} + \frac{1}{4} \cdot \frac{\mu(jd)^2}{kT_1}}{\frac{3}{2} \cdot \frac{n_1^2}{n_2} - n_1}$$

$V_1$  depends on the specifics of acceleration ( $n_2, j$ )

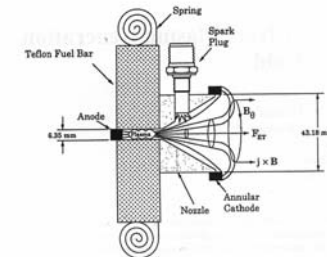
## Example: Electrothermal thruster



# Velocity at the Knudsen Layer Edge



Mikellides *et al*

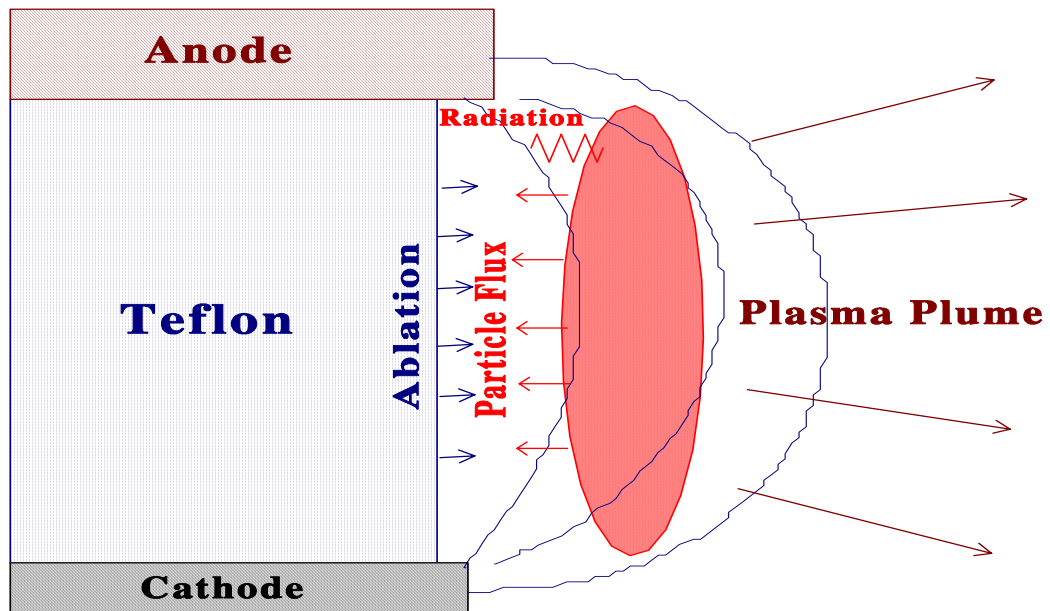


Keidar *et al* 2000

Electromagnetic acceleration leads to transition to vacuum evaporation regime

In addition to acceleration mechanism PPTs can be classified by ablation mode

# End-to-end simulation



ablation  
ionization

Plume expansion

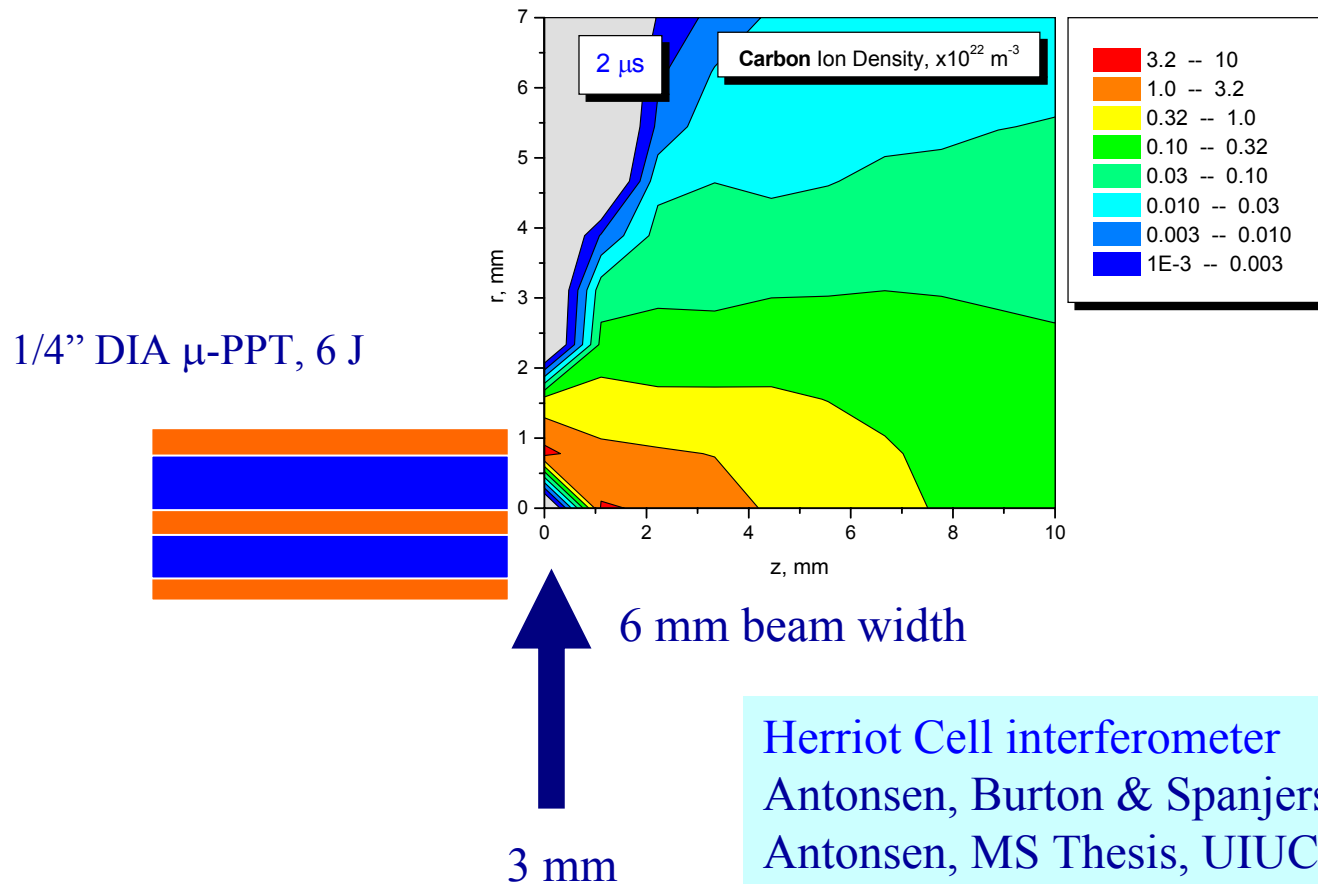
Magnetic diffusion

Fluid

Particle

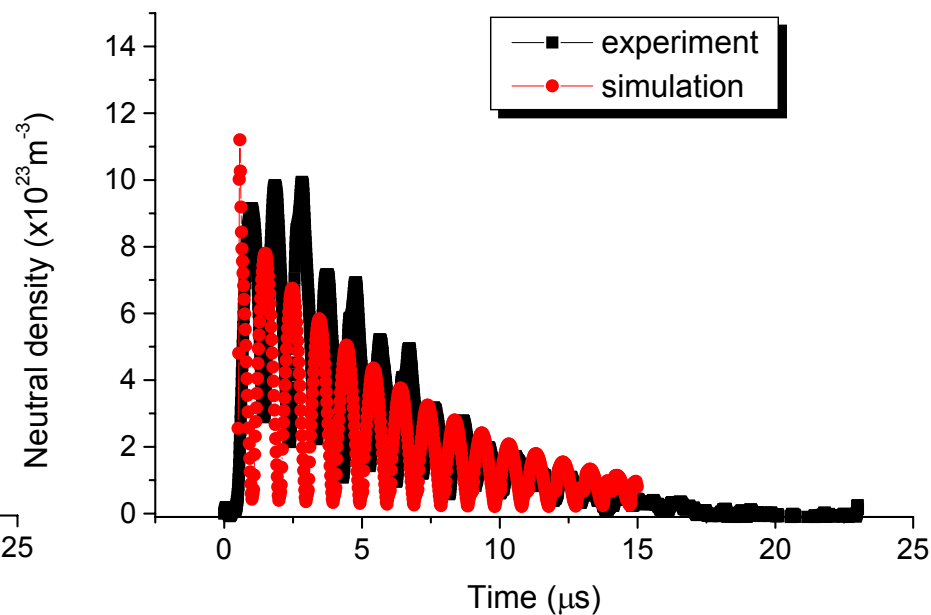
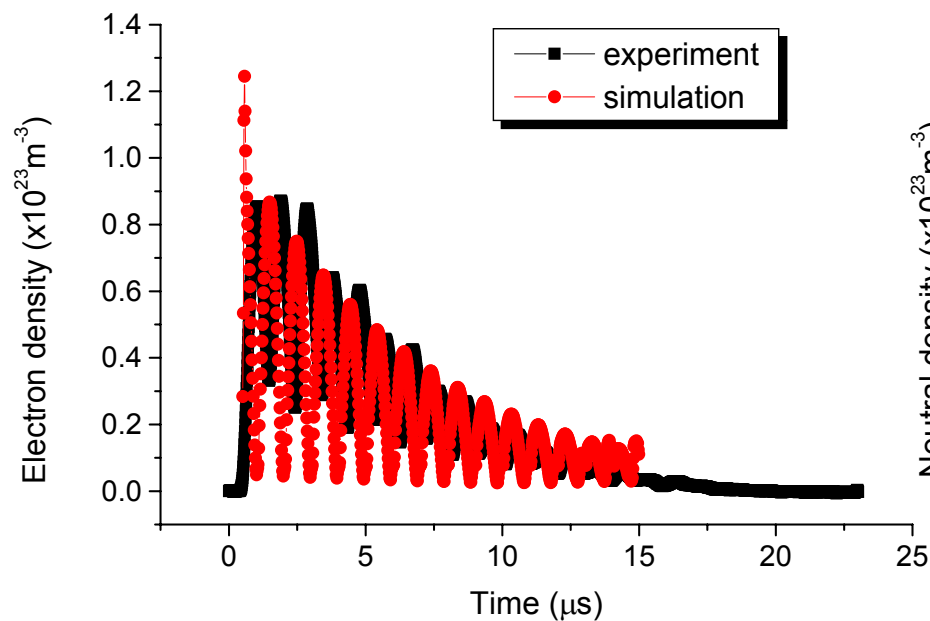


# Comparison with experiment (1)



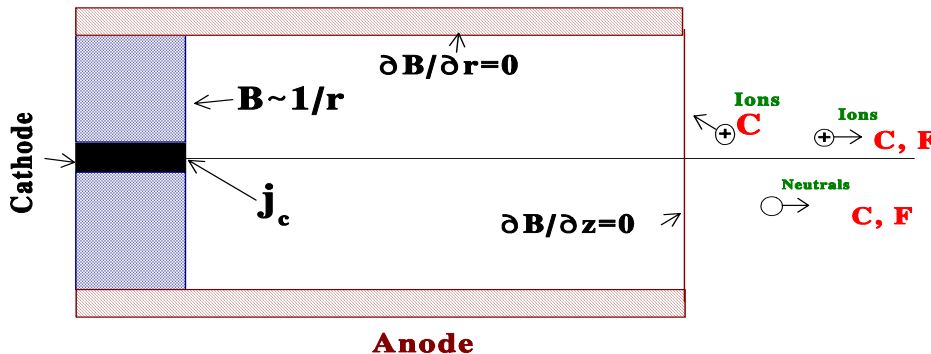
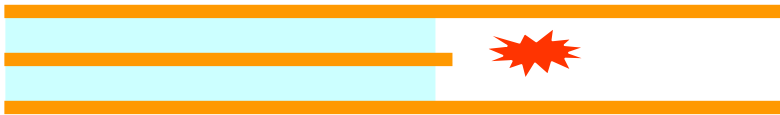
# Comparison with experiment (2)

1/4" DIA  $\mu$ -PPT, 6 J



Self-consistent non-equilibrium ionization model

# Propellant recession (1)

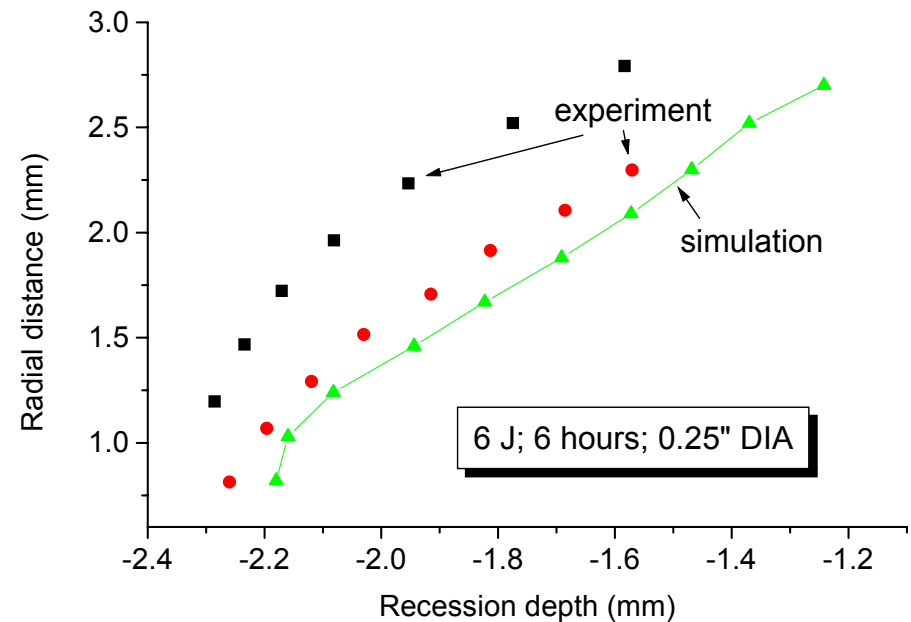
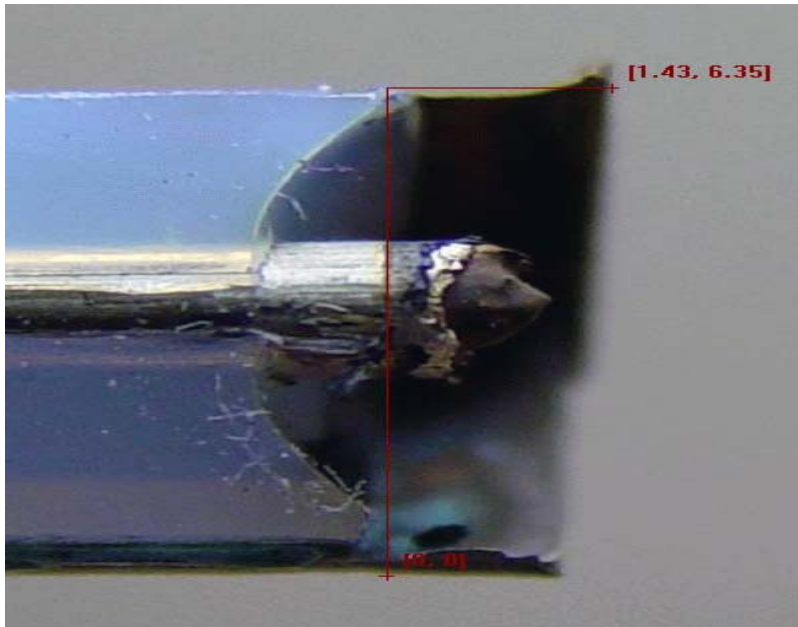


- 2D PIC-DSMC model & magnetic transport
  - time-dependent boundary conditions
  - plasma layer model
  - magnetic field & current distribution (energy balance & ion dynamics)
  - collisions (elastic & non-elastic)



# Propellant recession (2)

1/4" DIA, 6 J  
6 hours, 1Hz





# Ablation pattern: Charring

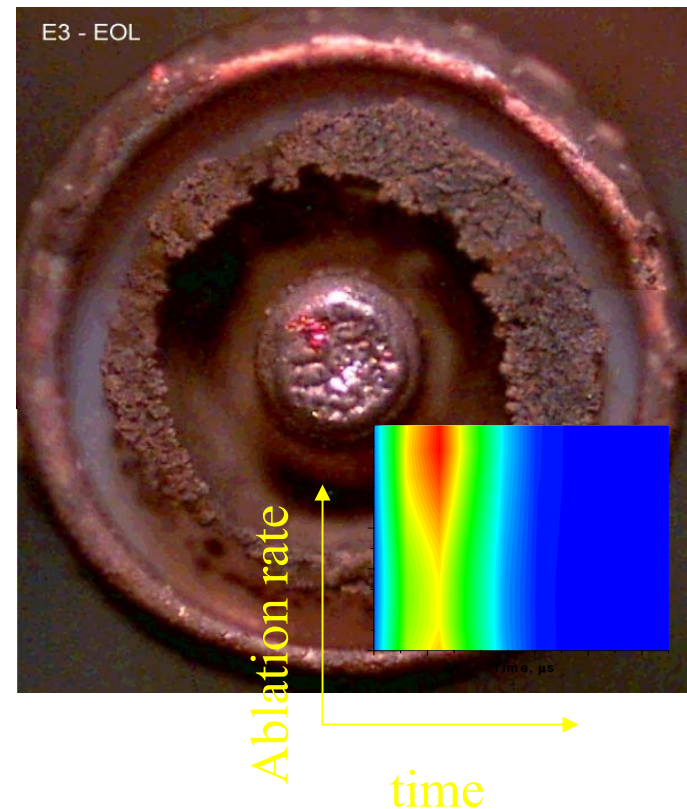


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Ablation rate calculations are based on plasma layer model and ablation theory

## AFRL Experiment:

Tests agree with model –  
Cold thrusters char easier

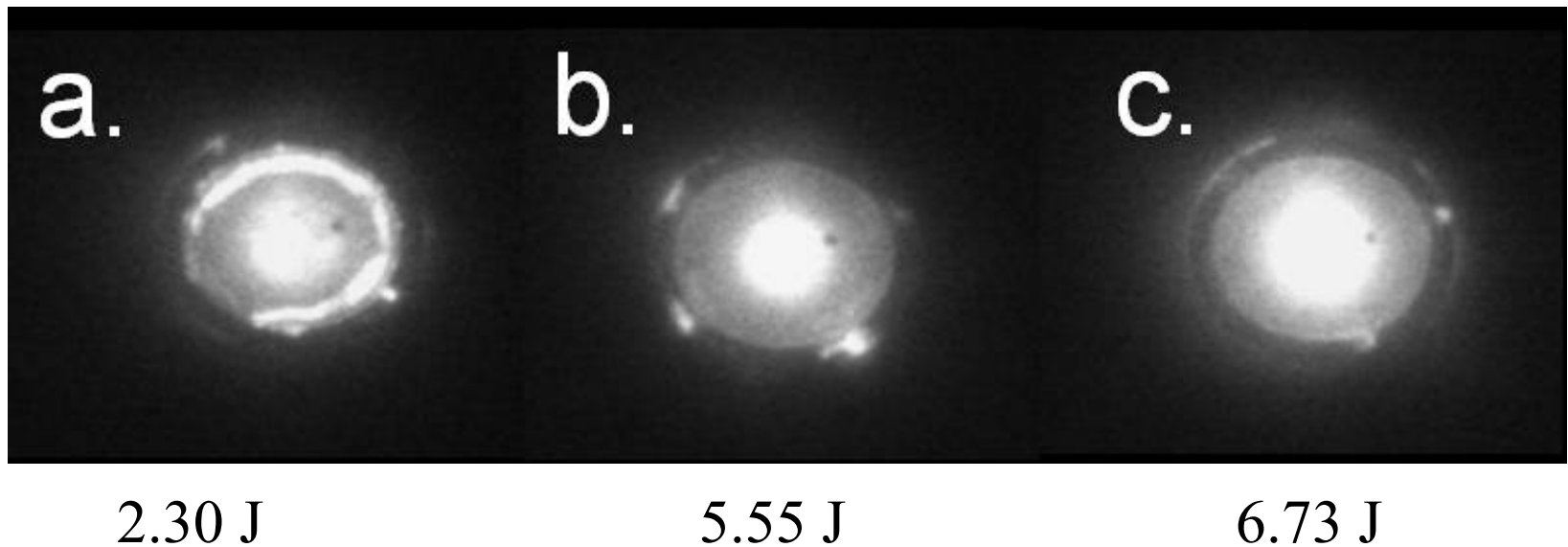


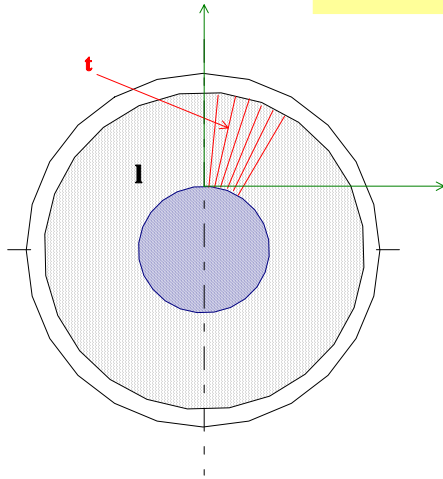


# Discharge non-uniformity

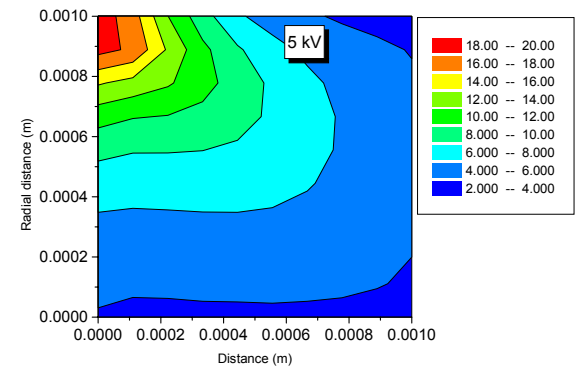
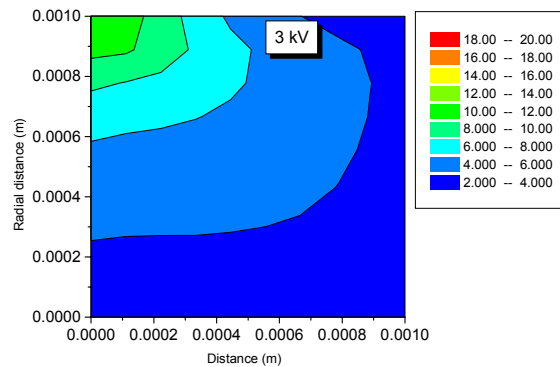
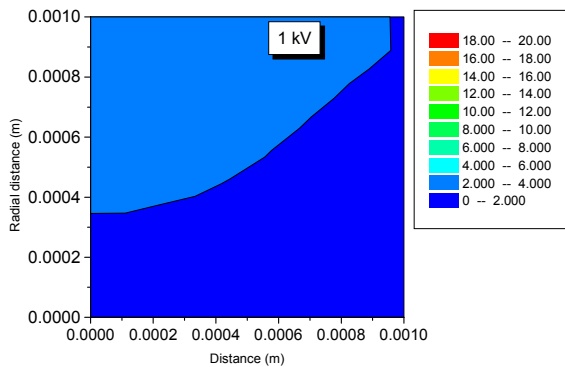
High speed camera  
visible emission

Arc spoking increases with energy

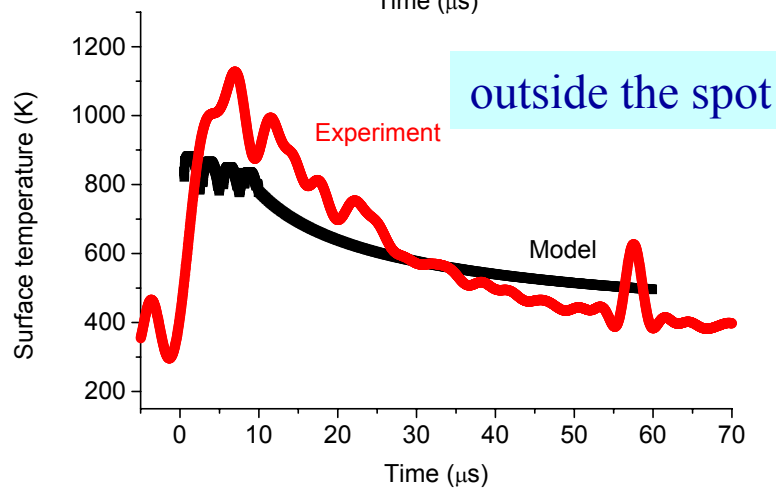
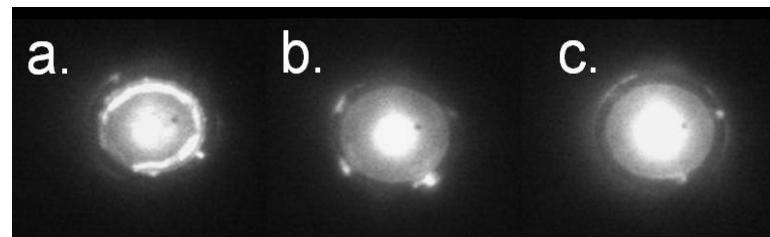
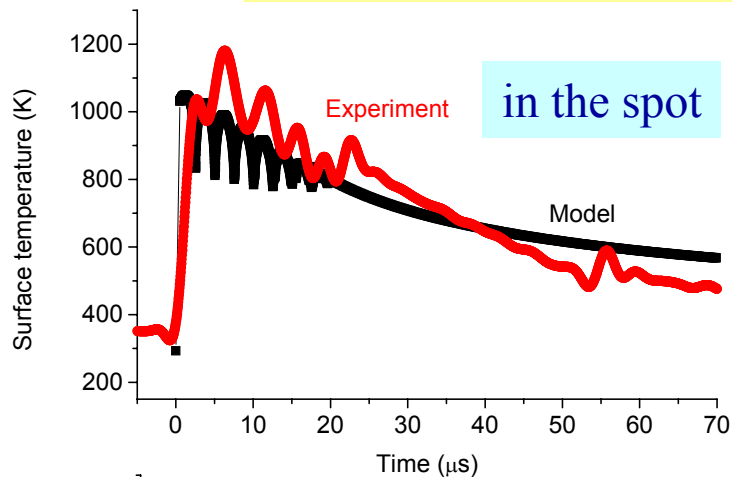




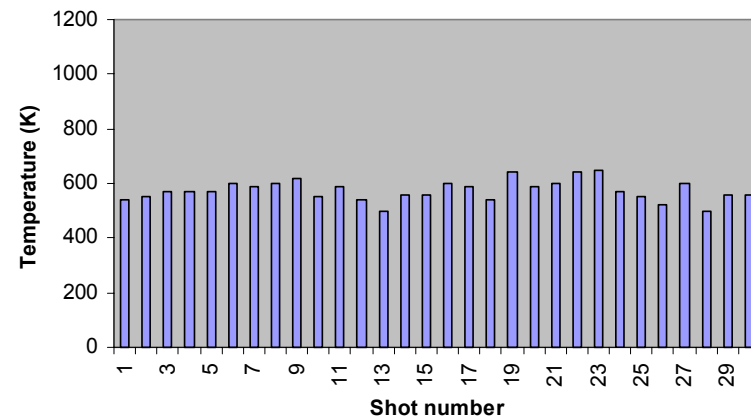
## Two-fluid MHD Calculated current density (normalized)



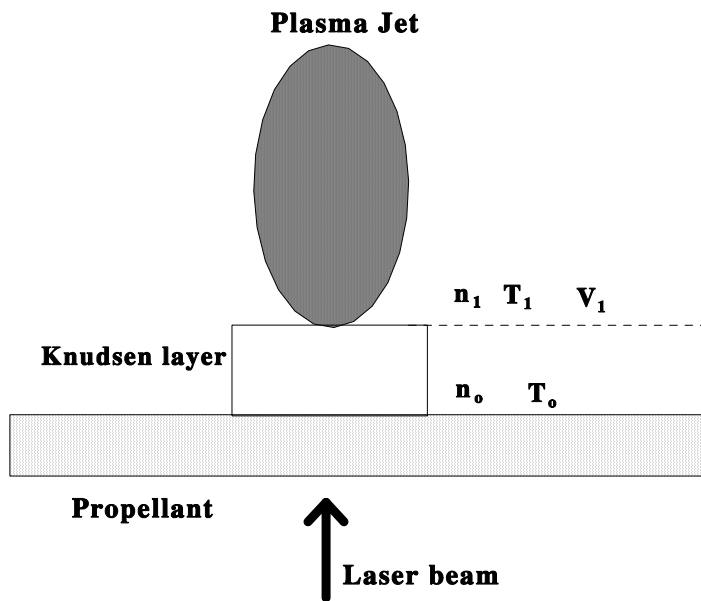
# Surface temperature (1)



13AUG Temperature at 30  $\mu\text{s}$   
10 J test



# Micro-Laser Plasma Thruster



- Energy equations:

$$\frac{3}{2}n_e V \partial T_p / \partial x = Q_{IB} - Q_{ei} - Q_\lambda$$

- Dominated by inverse-Bremsstrahlung

$$Q_{IB} = \alpha_{IB} I_0 \exp(-\alpha_{IB} x)$$

$$\alpha_{IB} = 1.37 \times 10^{-35} \lambda^3 N_e^2 T_e^{-\frac{1}{2}}$$

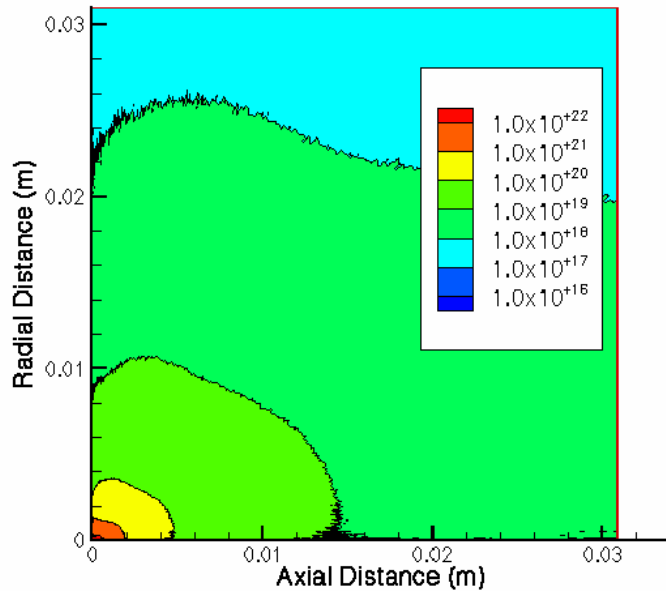
- Plasma properties:

- composition (C, H, C<sup>+</sup>, H<sup>+</sup>, Cl)
- assuming LTE

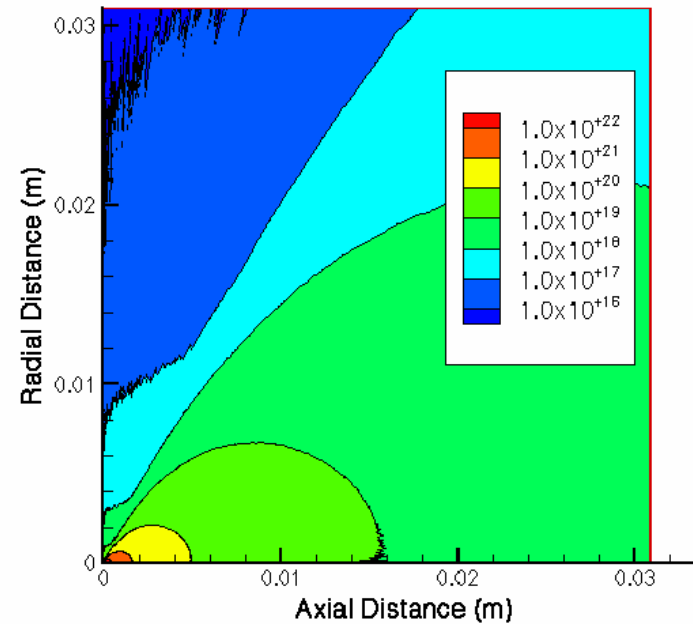


# Plume Simulation (PIC-DSMC)

$P=6.5 \times 10^{-5}$  torr



vacuum

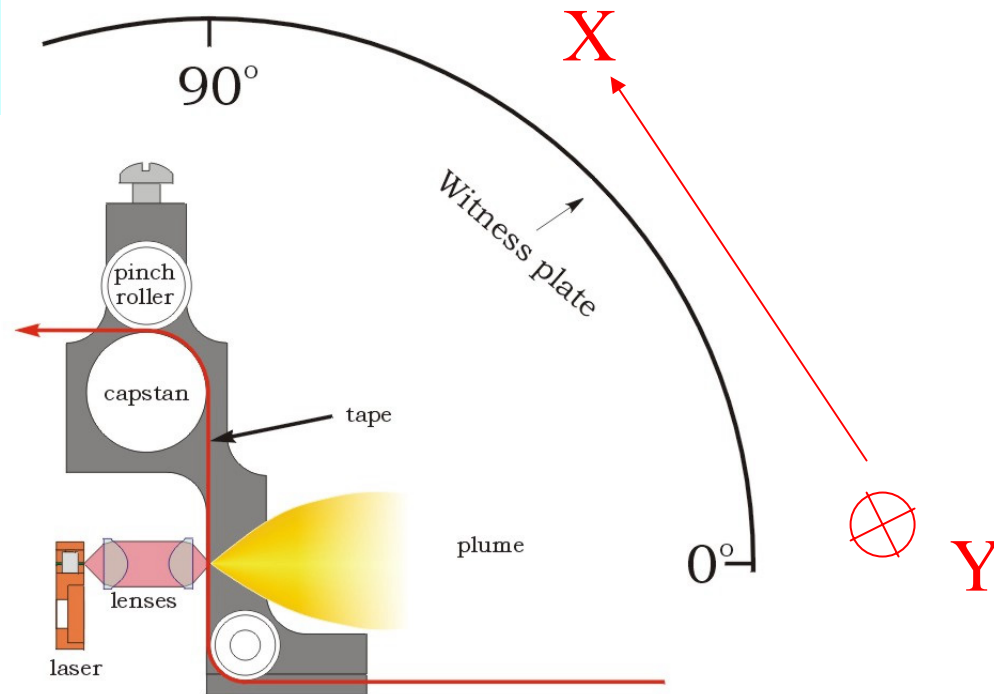


8 W



# Comparison with experiment (1)

Experimental set up  
Witness plate deposition

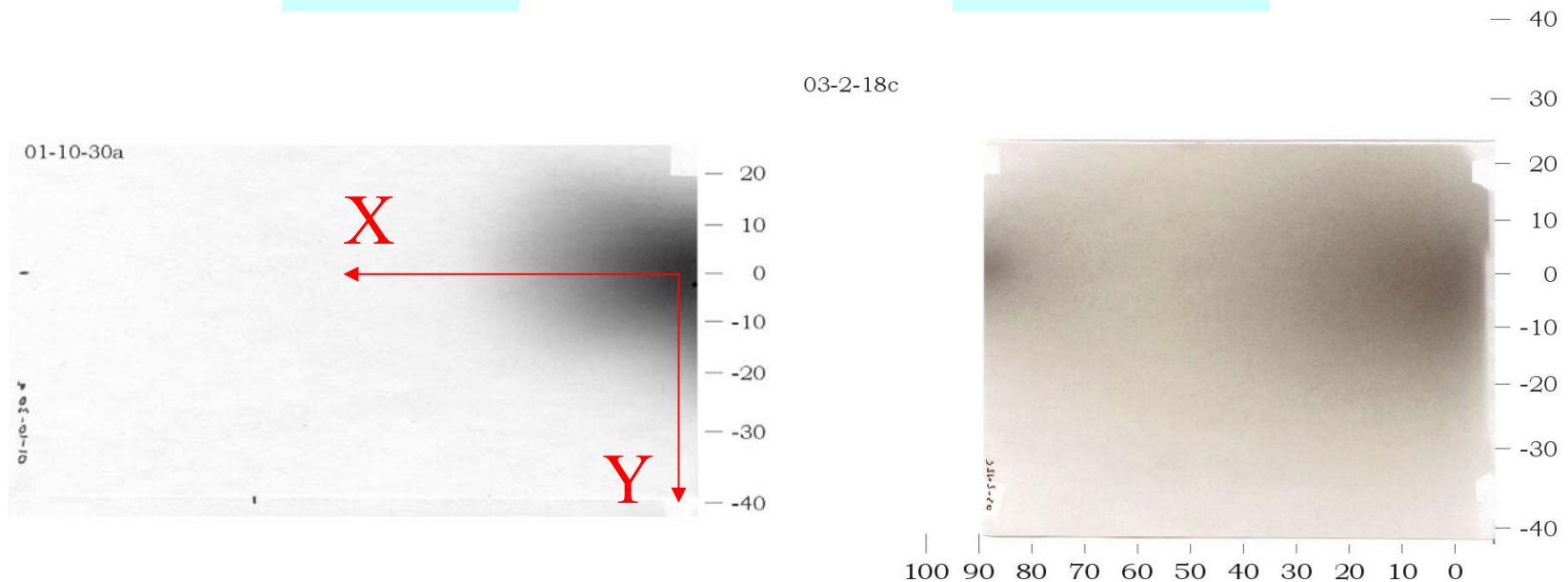




# Comparison with experiment (2)

$P=10^{-2}$  torr

$P=6.5 \times 10^{-5}$  torr



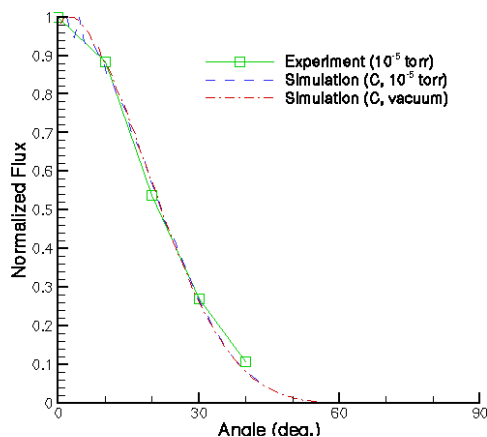
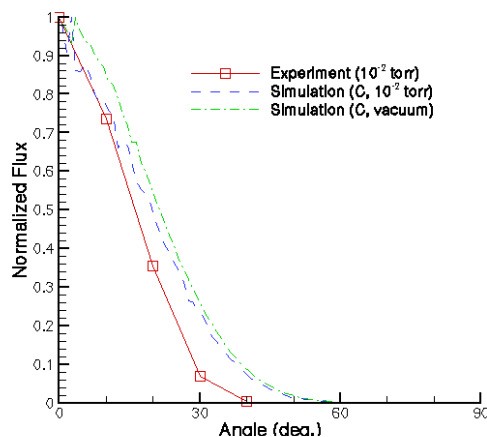
SEM analysis shows that deposition material is carbon  
Thus carbon flux is compared with deposition profiles

# Comparison with experiment (3)

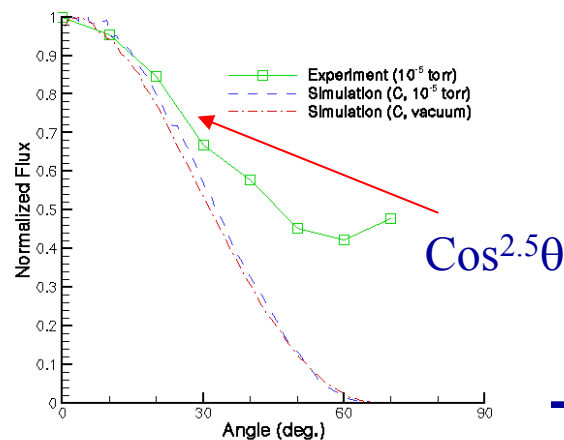
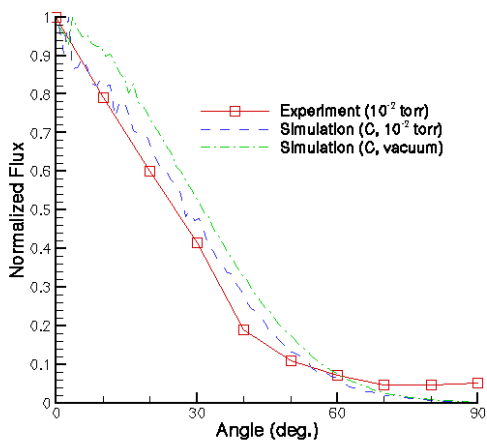
2.5 W;  $P=10^{-2}$  torr

8 W;  $P=6.5 \times 10^{-5}$  torr

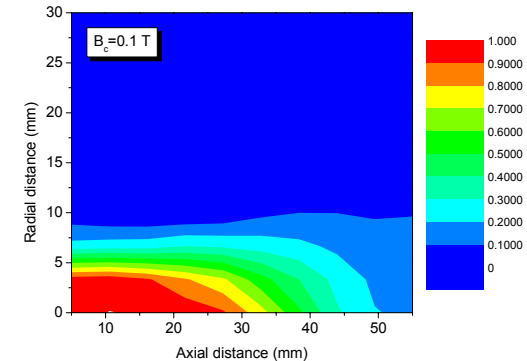
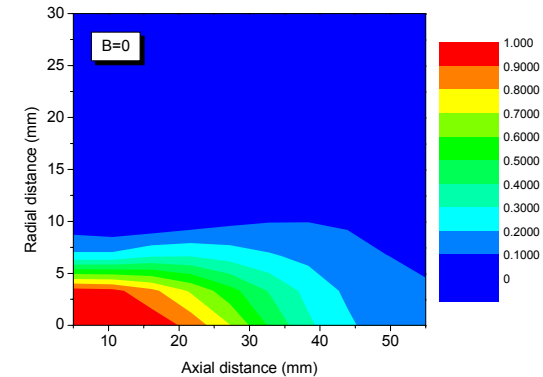
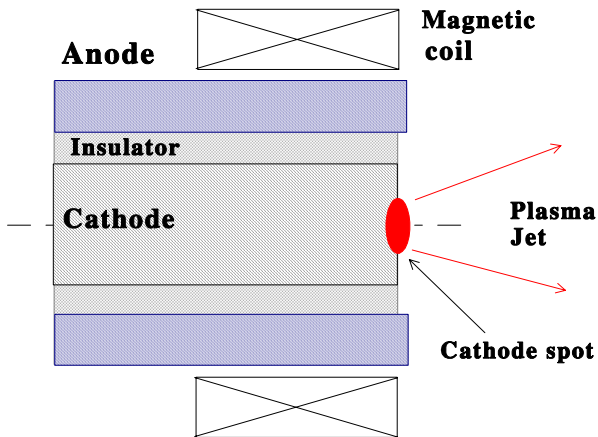
X



Y



# Micro-Vacuum Arc Thruster



MHD free boundary model

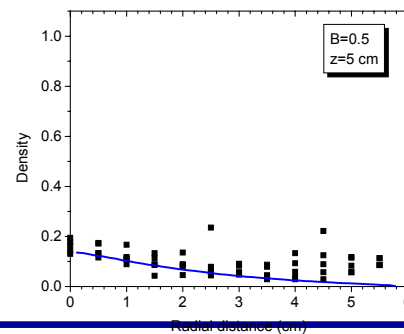
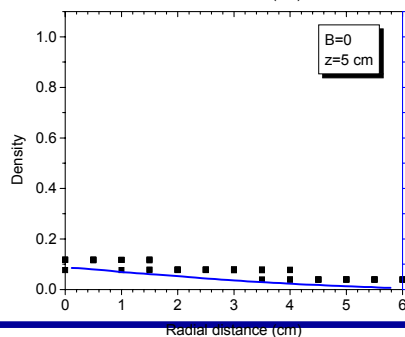
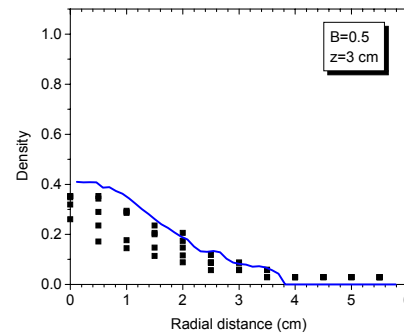
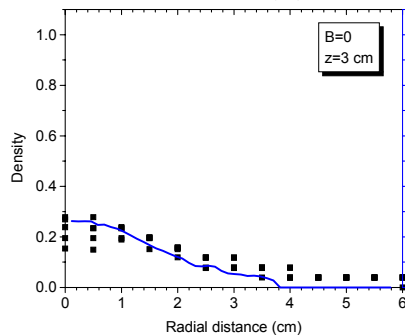
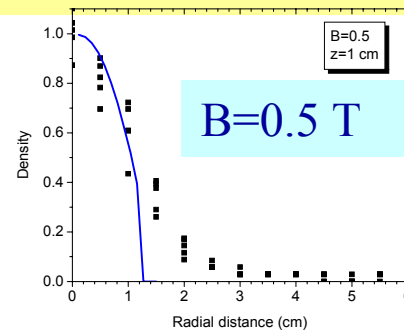
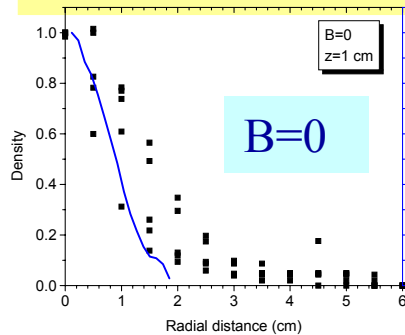
$$m_i (\mathbf{V}_i \cdot \nabla) \mathbf{V}_i = -k(Z_i T_e + T_i) \cdot \nabla \ln(n) + \mathbf{j} \times \mathbf{B} / n$$

$$\mathbf{j} = \sigma \{ \mathbf{E} + (k T_e / e) \cdot \nabla \ln(n) - \mathbf{j} \times \mathbf{B} / (en) + (\mathbf{V}_i \times \mathbf{B}) \}$$

$$\nabla \cdot (\mathbf{V}_i n) = 0$$

$$\nabla \cdot \mathbf{j} = 0$$

# Micro-Vacuum Arc Thruster Plume





# Summary (1)

- Various microthruster technologies based on ablative mechanism were developed

	$\mu$ PPT	$\mu$ VAT	$\mu$ LPT
$I_{sp}$ , s	1000	1000-3000	300-2000
$I_{bit}$ , $\mu$ N-s	1-10	1 [0.001-1]	0.001
T/P, $\mu$ N/W	$\sim$ 10	2-20	50-100
Dry mass, kg	0.5	0.3	0.5
Flexibility	low	some	high
Experimental data	a lot	some	some
Modeling status	high	some	some



## Summary (2)

- Self-consistent modeling approach for ablative micro-thrusters was formulated based on a kinetic ablation model and particle plume simulation.
- Most extensive validation of the modeling approach was performed for micro-pulsed plasma thruster. Plasma density, surface temperature, ablation rate, ablation profile were compared with experiment. Optimization criteria were formulated for some devices, such as microPPT.



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# Future needs

- Development of more flexible technology (variable  $I_{sp}$ , variable thrust)
  - $\mu$ LPT pulse duration
  - $\mu$ VAT pulse duration, material
- Contamination issues
  - Study is needed ( $\mu$ VAT)
- Lifetime issues (propellant recession)
  - $\mu$ VAT,  $\mu$ PPT
- Hybrid thrusters
  - $\mu$ VAT/ $\mu$ PPT;  $\mu$ LPT/ $\mu$ PPT
- Modeling: further characterization of thrusters ( $\mu$ VAT), plumes. Effect of the magnetic field